

SEE and TID Acceptance Tests of the Radiation Test-Bed for High Capacity Memory Components

Final Presentation of ESTEC Contract No. 1356/95/NL/FM, CCN-7

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25.05.2005

ESA D/TEC-QCA Final Presentation Day 2005
University of Jyväskylä, Jyväskylä, Finland

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Outline

1. Design of RTMC-3 Test-Bed
2. Verification of RTMC-3 with SRAMs
 - TID Test Verification
 - SEE Test Verification
3. Test and Evaluation of “state of the art” Memories:
SEE Tests of NAND Flash
4. Conclusions

1. Test-Bed Design Approach

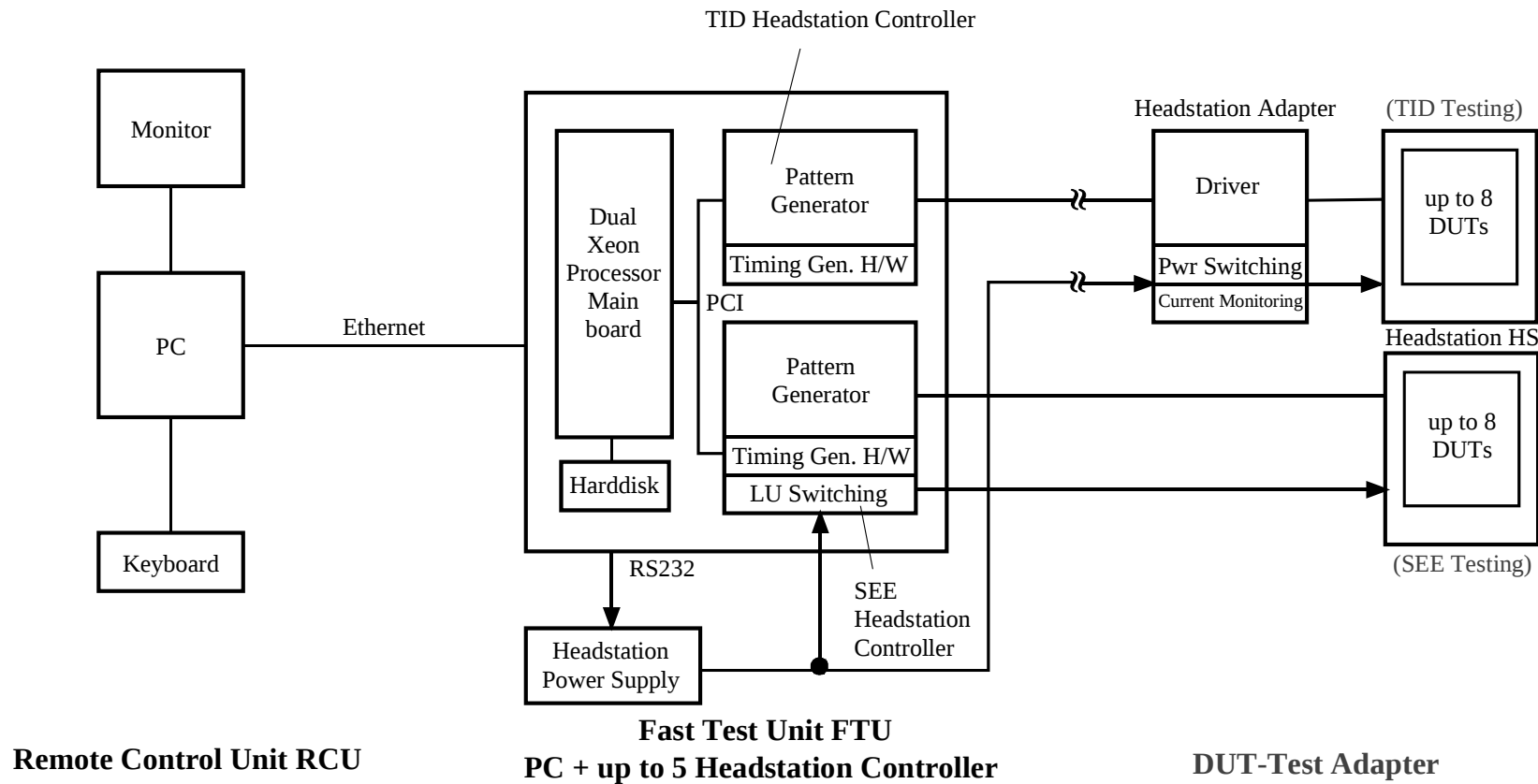
Test-Bed design mainly driven by four requirements:

- In situ testing
 - to detect and to isolate transient functional errors
- Real time event detection and recording
 - isolation of special SEE types (cluster errors, partial SEL)
 - complete testing of large capacity devices within reasonable test time
- Flexible and easily adaptable platform
 - test bed adaptable to sophisticated „memory systems on chip“ in a short time frame
- Flexible support of data evaluation

1. Test-Bed Implementation

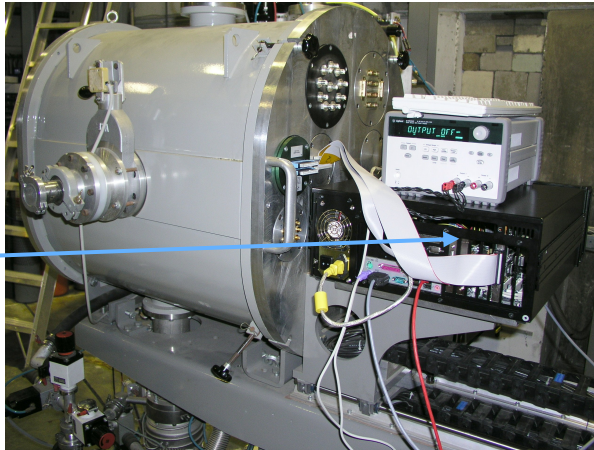
- PC based H/W supported system (Fast Test Unit) with special plug-in cards for real time functions of TID and SEE-tests (Head Station Controller)
 - Adaptable device control and test patterns implemented in firmware within configurable XILINX FPGA's
- Easily configurable test-bed S/W IDA GSEOS V
 - Operational and loop control
 - Quick-Look data analysis to support in-situ tests
 - Detailed data evaluation after tests
- Remote control of in-situ tests via network

1. RTMC-3 Block Diagram



1. RTMC-3 Test-Bed

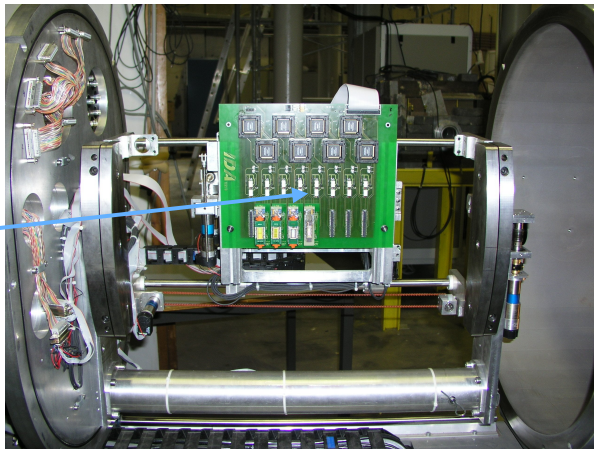
FTU



RCU



HS-SEE



HS-TID

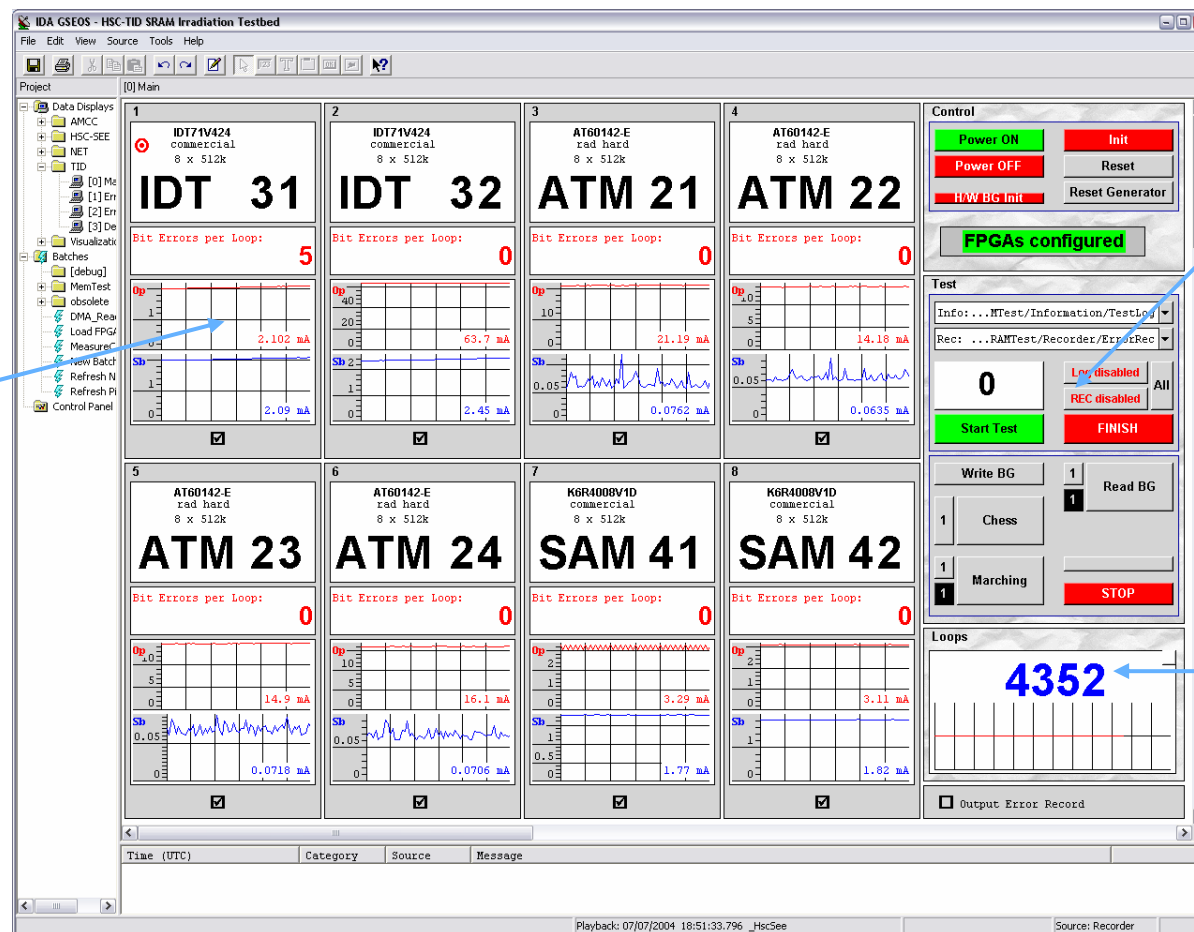


2. TID-Test Verification

- Test Facility: ESTEC Co60, ~3600 rad/hour
 - Devices: SRAM, 8 DUTs:
(Atmel AT60142-E, IDT IDT71V424L12PHI,
Samsung K6R4008V1D)
- Test-Bed:
 - Autonomous simultaneous in-situ test of all 8 DUTs
 - Continuous measurement of active/stand-by currents
 - Complete recording of events, i.e. currents, data errors and device failures
 - Real time visualization of all data
 - Autonomous S/W supported over-current protection

2. TID-Test Verification

**DUT
Quick-look
(error counts,
currents,
device failures)**

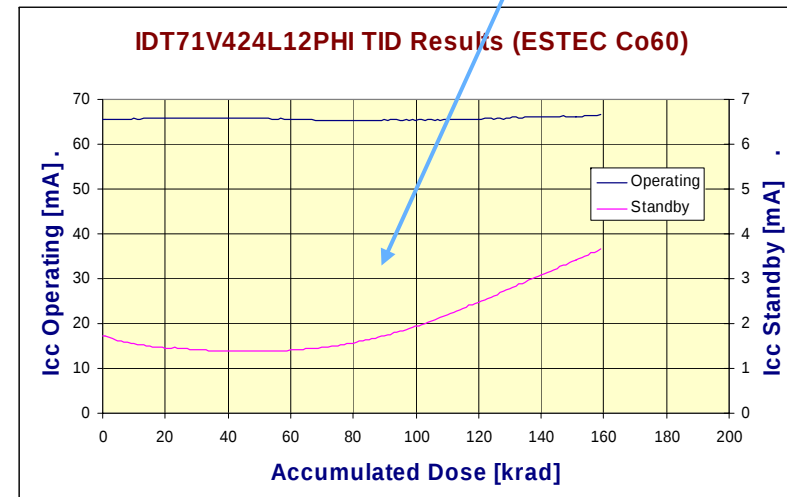
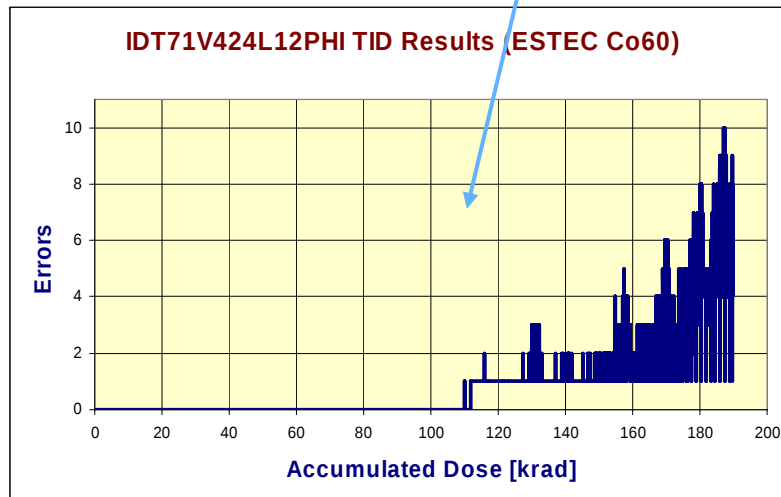


**Operational
Control**

Loop Counter

2. TID-Test Verification

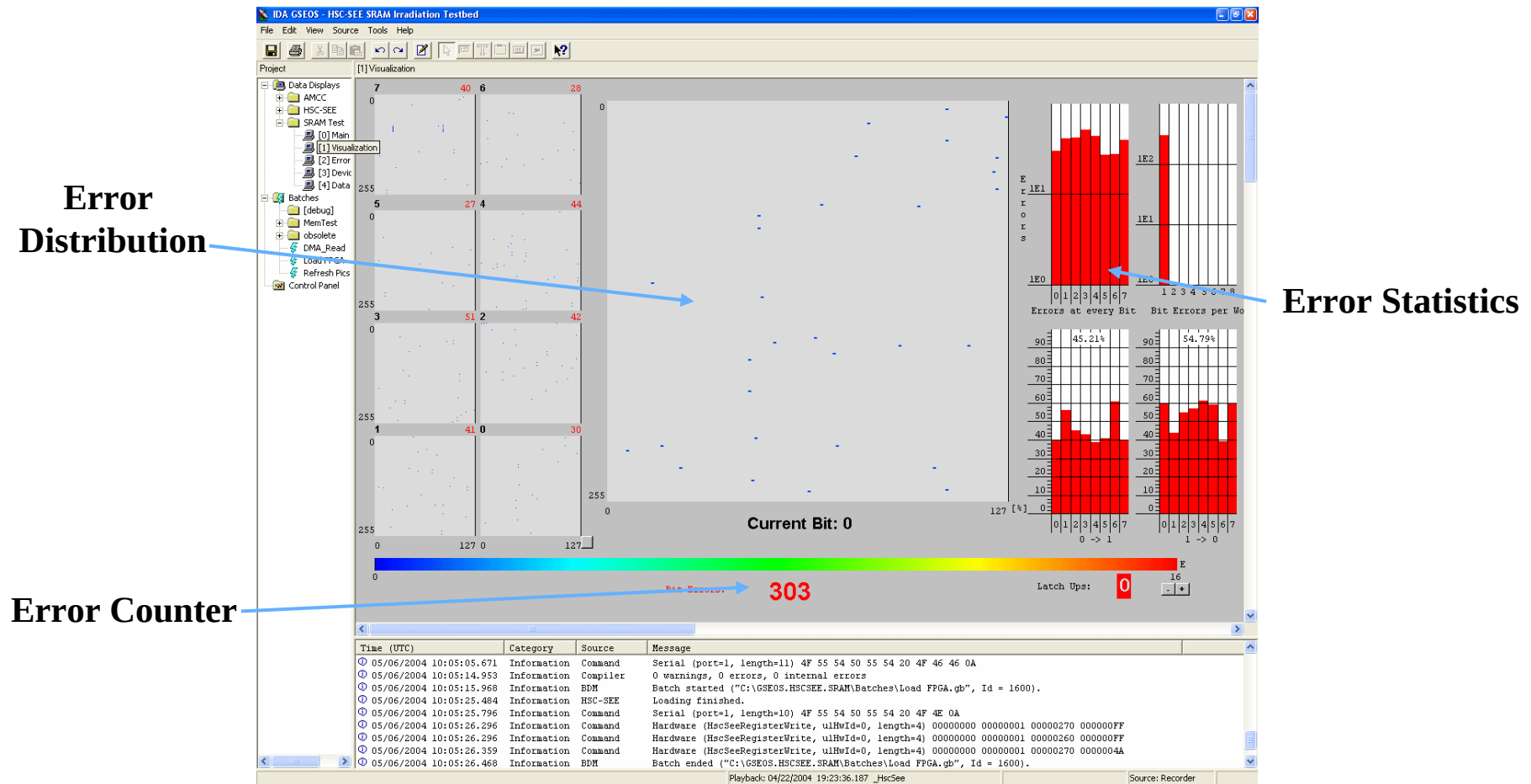
Type	1 st Error, D [krad]	Device Failure, D [krad]	Current Increase, D [krad]
Atmel AT60142-E	>167.40	>167.40	-
Atmel AT60142-E	>167.40	>167.40	-
Atmel AT60142-E	>167.40	>167.40	-
Atmel AT60142-E	128.98	>167.40	-
IDT IDT71V424L12PHI	110.04	>189.72	88.50
IDT IDT71V424L12PHI	136.46	>159.00	85.30
Samsung K6R4008V1D	>189.72	>189.72	-
Samsung K6R4008V1D	7.96	>130.67	-



2. SEE-Test Verification

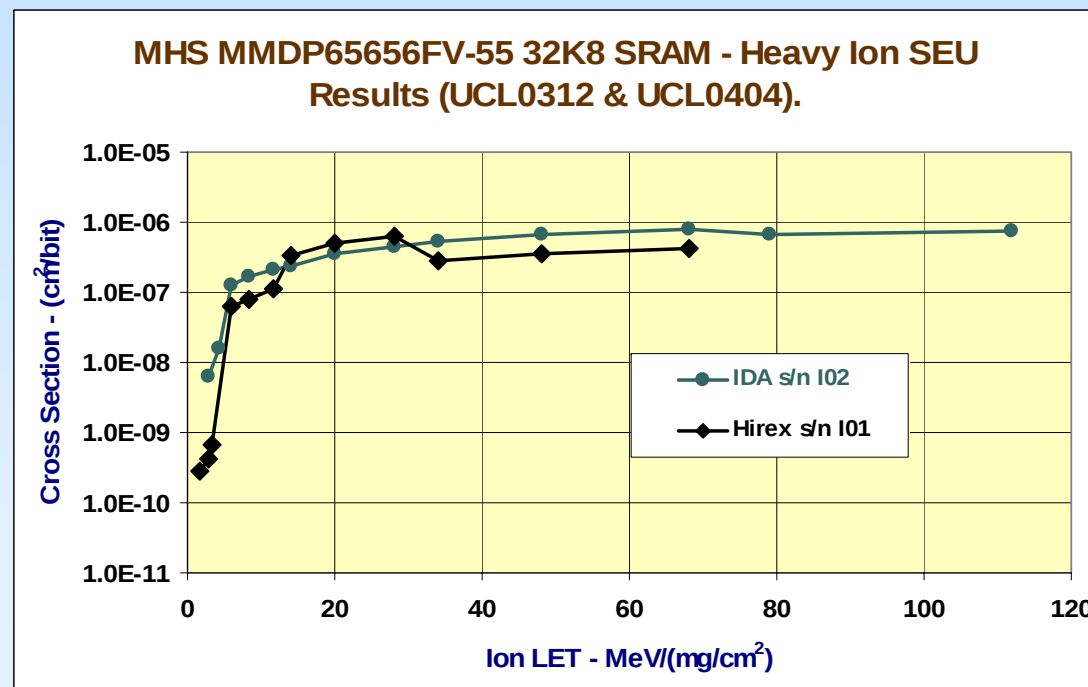
- Test Facility: HIF at UCL, low penetration beam $M/Q \sim 5$, LET 2.97...111.8 MeV/mg/cm²
- Devices: SRAM, 6DUTs:
(Atmel AT60142-E, MHS MMDP65656EV-45, MMDP65656FV-55, White WMS512K8-70DEM, WMS512K8-45DEM)
- Test-Bed:
 - Autonomous in-situ tests of all single DUTs
 - Complete recording of anomaly events, i.e. data errors, device failures and latch-up's
 - Real time visualization of all data
 - Autonomous H/W supported fast latch-up protection (<5μsec)

2. SEE-Test Verification



2. SEE-Test Verification

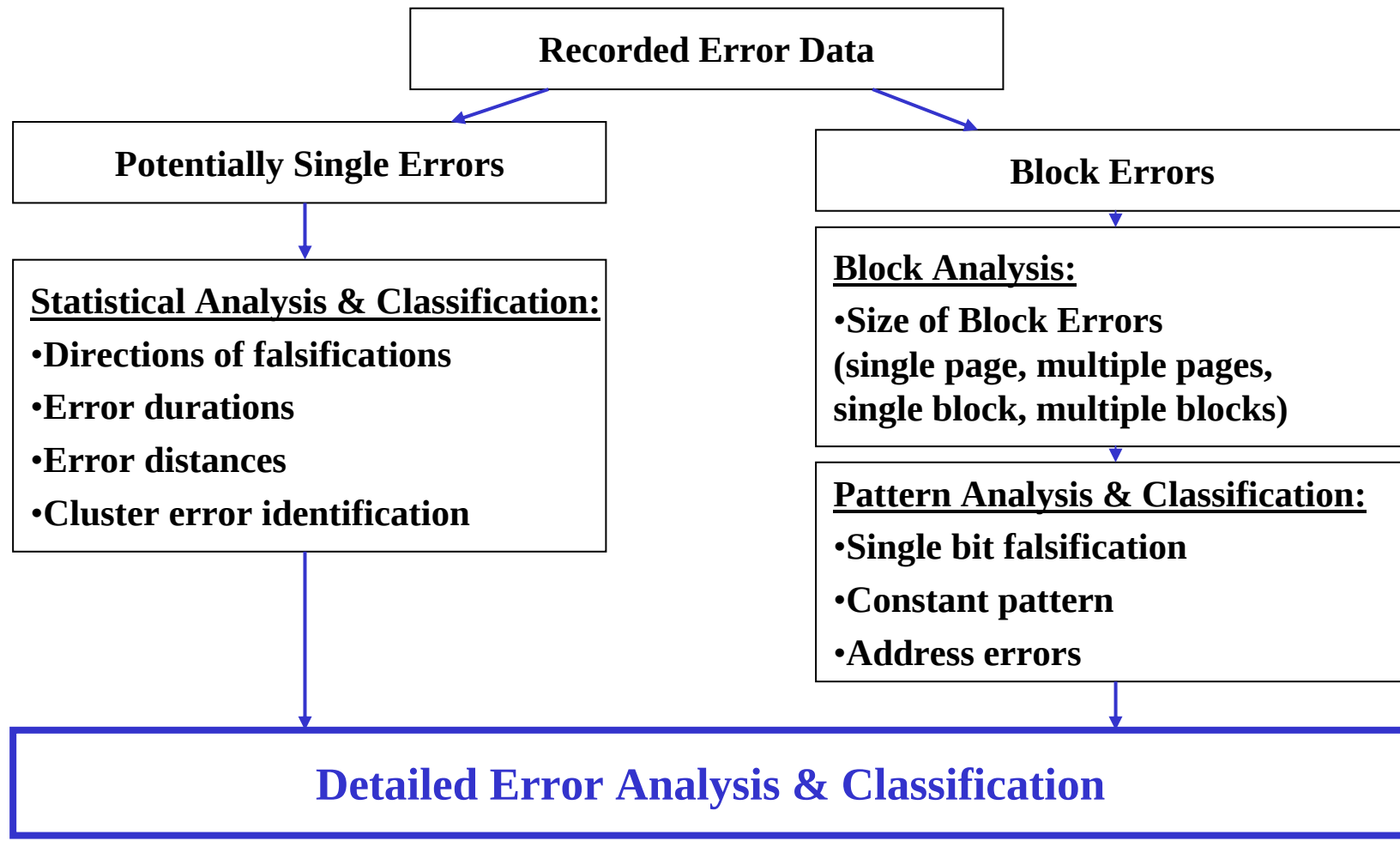
- RTMC-3 SEE-Test results are well compliant with previous measurements:



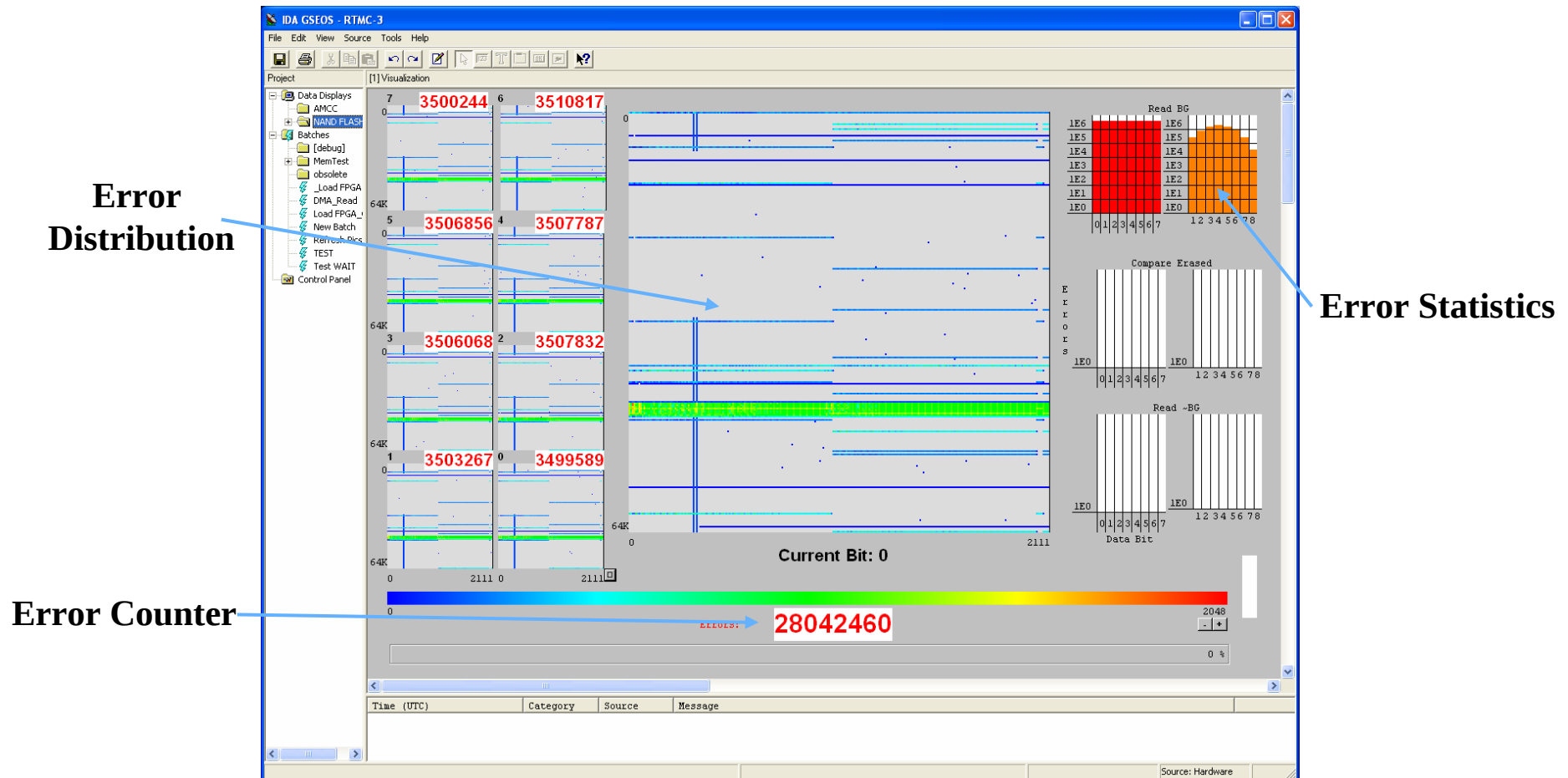
3. SEE-Test Evaluation Capabilities

- Quick-Look data analysis during test
 - Error counts
 - Visualization of error distribution (statistically, physically/logical)
- Detailed data analysis after test
 - Replay of error event data (real-time, single step, time scaled)
 - User definable data filtering for error analysis and classification after test

3. SEE-Test Evaluation



3. SEE-Test Evaluation Quick-Look



4. Conclusions

- RTMC-3 is verified and available for SEE- and TID-testing
- Feasibility for “state of the art” memory device tests and evaluation support demonstrated
- Further tests of complex devices (SDRAM, system on chip devices) in preparation